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OFFICIAL
Response Under 37 C.F.R. § 1.116
Expedited Procedure
Examining Group 1765

PATENT
Docket No. 150.0056 0102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Whonchee Lee et al.)	Group Art Unit:	1765
)		
Serial No.: 09/560,268)	Examiner:	Deo, Duy Vu
Confirmation No.: 2517)		
)		
Filed: 26 April 2000)		
)		
For: COMPOSITION FOR SELECTIVELY ETCHING AGAINST COBALT			
			SILICIDE (As Amended)

RESPONSE UNDER 37 C.F.R. § 1.116

Assistant Commissioner for Patents
BOX AF
Washington D.C. 20231

Dear Sir:

In response to the Office Action dated 4 February 2002, please consider the following remarks:

Remarks

The Office Action dated 4 February 2002 has been received and reviewed. The pending claims are claims 64-93. Reconsideration and withdrawal of the rejections are respectfully requested.

The 35 U.S.C. § 103(a) Rejection

The Examiner rejected claims 64-93 under 35 U.S.C. § 103(a) as being unpatentable over Tsai et al. (U.S. Patent No. 5,486,266) in view of Thiel (U.S. Patent No. 4,316,765). Applicants